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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: 2813

Serial No.: 10/517,765

Examiner: **MCCALL SHEPARD, Sony**

Filed: **February 3, 2006**

P.T.O. Confirmation No.: 6791

**FOR: SUBSTRATE TREATING APPARATUS AND METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE**

**RESPONSE UNDER 37 CFR §1.116**

**- EXPEDITED RESPONSE -  
GROUP ART UNIT 2813**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 27, 2009

Sir:

In response to the Final Office Action dated December 1, 2008, extended from March 1, 2009 to May 1, 2009 by a two (2) month Petition for Extension of Time, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.